



PATENT  
Docket No. 204552021700

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*Deborah S. Gladstein*  
Deborah S. Gladstein

*7/3/03*  
*Handwritten signature*  
*A. Reed*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

*3/3/03*

In the application of:

Tetsuyoshi INOUE et al.

Serial No.: 09/987,010

Filing Date: November 13, 2001

For: SEMICONDUCTOR LASER  
MANUFACTURING METHOD AND  
SEMICONDUCTOR LASER

Examiner: Tuan N. Nguyen

Group Art Unit: 2828

AMENDMENT UNDER 37 CFR 1.111

Commissioner for Patents  
Washington, D.C. 20231

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Sir:

This is in response to the Office Action dated November 19, 2002. Please amend the application as follows.